

Test Report

HSI-CHIN ELECTRONICS CO., LTD.
4F, NO. 194, SEC. 3, TA TUNG RD., HSI CHIH CITY, TAIPEI
HSIEN, TAIWAN R. O. C.

Report No. : CE/2005/86895
Date : 2005/09/06
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The following merchandise was (were) submitted and identified by the client as :

Type of Product : PLASTIC PARTS: USB SERIES (GP)
Buyer/Order No : SONY
Sample Received : 2005/08/30
Testing Date : 2005/08/30 TO 2005/09/06

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Test Result : - Please see the next page -


Daniel Yeh, M.R. / Operation Manager
Signed for and on behalf of
SGS TAIWAN LTD.

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Test Result

PART NAME NO.1 : BLACK PLASTIC (PLEASE REFER TO THE PHOTO ATTACHED)

Test Item (s):	Unit	Method	MDL	Result
				No.1
Monobromobiphenyl	%	With reference to USEPA3540C or USEPA3550C. Analysis was performed by HPLC/DAD, LC/MS or GC/MS. (prohibited by 2002/95/EC (RoHS), 83/264/EEC, and 76/769/EEC)	0.0005	N.D.
Dibromobiphenyl	%		0.0005	N.D.
Tribromobiphenyl	%		0.0005	N.D.
Tetrabromobiphenyl	%		0.0005	N.D.
Pentabromobiphenyl	%		0.0005	N.D.
Hexabromobiphenyl	%		0.0005	N.D.
Heptabromobiphenyl	%		0.0005	N.D.
Octabromobiphenyl	%		0.0005	N.D.
Nonabromobiphenyl	%		0.0005	N.D.
Decabromobiphenyl	%		0.0005	N.D.
Total PBBs (Polybrominated biphenyls)/Sum of above	%		-	N.D.
Monobromobiphenyl ether	%	With reference to USEPA3540C or USEPA3550C. Analysis was performed by HPLC/DAD, LC/MS or GC/MS. (prohibited by 2002/95/EC (RoHS), 83/264/EEC, and 76/769/EEC)	0.0005	N.D.
Dibromobiphenyl ether	%		0.0005	N.D.
Tribromobiphenyl ether	%		0.0005	N.D.
Tetrabromobiphenyl ether	%		0.0005	N.D.
Pentabromobiphenyl ether	%		0.0005	N.D.
Hexabromobiphenyl ether	%		0.0005	N.D.
Heptabromobiphenyl ether	%		0.0005	N.D.
Octabromobiphenyl ether	%		0.0005	N.D.
Nonabromobiphenyl ether	%		0.0005	N.D.
Decabromobiphenyl ether	%		0.0005	N.D.
Total PBDEs (PBDEs)(Polybrominated biphenyl ethers)/Sum of above	%		-	N.D.

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Test Item (s):	Unit	Method	MDL	Result
				No.1
Chromium VI (Cr+6)	ppm	UV-VIS after reference to US EPA 3060A.	2	N.D.
Cadmium (Cd)	ppm	ICP-AES after reference to EN 1122, method B:2001 or other acid digestion.	2	N.D.
Mercury (Hg)	ppm	ICP-AES after reference to US EPA 3052 or other acid digestion.	2	N.D.
Lead (Pb)	ppm	ICP-AES after reference to US EPA 3050B or other acid digestion.	2	11.1

- NOTE: (1) N.D. = Not detected (<MDL)
 (2) ppm = mg/kg
 (3) MDL = Method Detection Limit
 (4) " - " = No Regulation

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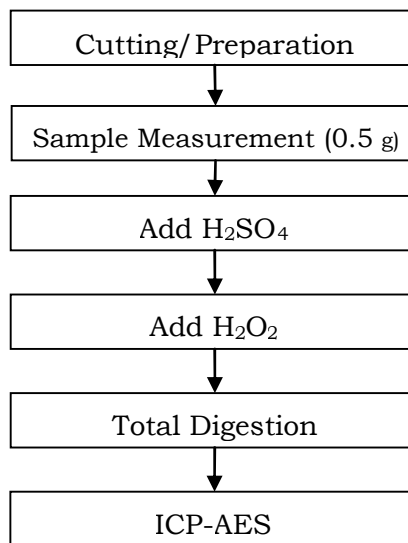
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Per requirements of SONY QAR-05-002:

- 1) These samples were dissolved totally by pre-conditioning method according to below flow chart.
- 2) Name of the person who made measurement: Anren Lee
- 3) Name of the person in charge of measurement: Daniel Yeh

Flow Chart of Digestion for Plastic – EN1122 for Cd (without residue)



Test Report

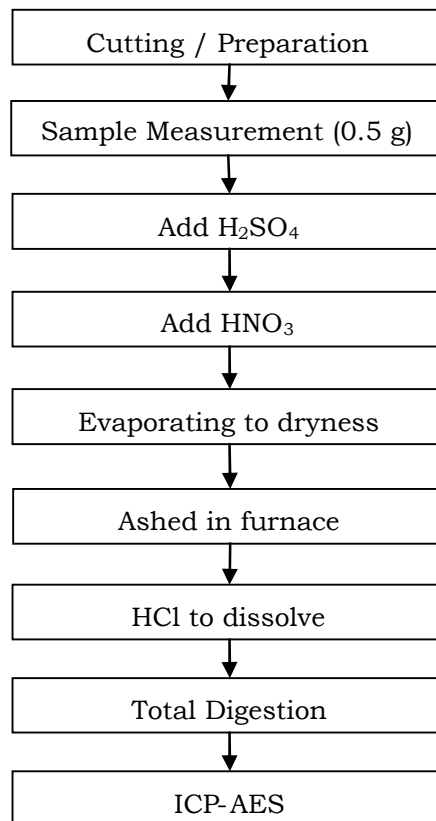
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Per requirements of SONY QAR-05-002:

- 1) These samples were dissolved totally by pre-conditioning method according to below flow chart.
- 2) Name of the person who made measurement: Anren Lee
- 3) Name of the person in charge of measurement: Daniel Yeh

Flow Chart of Digestion for Plastic –Wet Decomposition for Pb (without residue)



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